

REPORT: CVD diamond Cutting by Laser-MicroJet[®]



TASK

The Laser-MicroJet[®] technology has been tested for cutting CVD diamond plates.

The goal of this study is to demonstrate the feasibility and the quality of our process and to give an estimation of the cutting time of the Laser MicroJet process on CVD diamond.

Three pieces of different dimensions were processed with straight line cuts, as requested by the customer.

The samples were glued on a metallic mount, hold up with a clamp.

	Project Leader	Responsible Application Group	
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Date:	2013	Date:	2013
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SAMPLE DESCRIPTION AND PREPARATION

SAMPLE A	Material	CVD diamond
	Size	7.0 x 7.0 mm ²
	Thickness	~ 2 mm
	Quantity	1 <i>pc</i>
SAMPLE B	Material	CVD diamond
	Size	$6.5 \times 6.5 \ mm^2$
	Thickness	~ 2 <i>mm</i>
	Quantity	1 <i>pc</i>
SAMPLE C	Material	CVD diamond
	Size	10 x 10 <i>mm</i> ²
	Thickness	~ 2 <i>mm</i>
	Quantity	1 <i>pc</i>

PROCESS: INSTRUMENT & TEST PARAMETERS

For these experiments, the DCS 150 equipped with a frequency-doubled Q-switched Nd-YAG laser has been used as the machine configuration in our lab.

The major advantages of Laser-MicroJet[®] technology with regards to your application are:

- Parallel and smooth cut walls
- Negligible heat damage to the material
- Cutting of arbitrary shapes

In the table below, the optimized processing parameters used in the experiments are summarized:

	SYSTEM	Machine type	DCS 150
	MICROJET [®] PARAMETER	Nozzle diameter	40 µm
		MicroJet [®] diameter	~33 µm
		Water pressure	400 <i>bar</i>
		Assist gas	1.1 I/min of He
	LASER PARAMETER	Laser type / Wawelength	L51G / 532 nm
		Average power	28 W
		Power in WaterJet	13 W
		Pulse frequency	6 kHz
		Pulse width	~120 <i>ns</i>



RESULTS

The following image shows three samples (2 **Sample 2** pieces and one **Sample 3**) on one of their processed side.



PICTURE 1: Image of Sample 2 and 3 parts after process, from one of the cut sides

• Results on **Sample A** (7.0 x 7.0)

	CUTTING PARAMETER	Cutting speed	5 <i>mm/</i> s
Sec.		Number of passes	400
	→ Sample A	Overall Process time	12:15 <i>min:sec</i>
		Ablation rate	18 µm / per pass

One slice has been produced with the **Sample A**. The thickness is ~650 μ m.

• Results on **Sample B** (6.5 x 6.5)

CUTTING PARAMETER	Cutting speed	5 <i>mm/s</i>
	Number of passes	360
→ Sample B	Overall Process time	10:30 <i>min:sec</i>
	Ablation rate	18 μm / per pass

Two slices have been produced with the **Sample B**. The thicknesses are ~605 and ~645 µm.



• Results on **Sample C** (10 x 10)

	CUTTING PARAMETER	Cutting speed	5 <i>mm</i> /s
State of the second		Number of passes	800
	→ Sample C	Overall Process time	30:20 <i>min:sec</i>
		Ablation rate	12 μm / per pass

One slice has been produced with the **Sample C**. The thickness is ~650 μ m.

• Results on **Sample S**

We used the remaining part of sample C, that we called **Sample S**, to groove a 80% deep channel. This will allow you to observe the parallelism and thinness of our cutting tool.

Pictures

The following microscope pictures give an overview on the quality obtained with the Laser-MicroJet[®] technology on the **CVD diamond** samples.



PICTURE 2: Microscope image of the cut wall, top right corner (dark field illumination)



PICTURE 3: Microscope image of the cut wall, middle left side (dark field illumination)



APPLICATION REPORT

• Results analysis

- Width of the cut

Using a 40 μ m nozzle, we obtain a cut width of ~ 45 μ m, all along the 10 mm thickness of your sample. There is a very small widening of the kerf on the first 50 μ m at the extremities of the sample. This is why it is very difficult to estimate the kerf width with a visual inspection.

- Roughness

The roughness of the process on CVD diamonds is \sim 0.3 µm Ra. This is an average of several measurements taken on the surfaces of the cut samples.

- Sample thicknesses

The thicknesses of the parts are not the same. We did several tests to determine precisely the cutting width of our tool on your diamond. You should not worry about it. This will be perfectly under control once the tool correction has been determined.

CONCLUSION

The cutting of CVD diamonds was investigated on SYNOVA LCS 150. This machine is based on the MicroJet[®] technology and combines the advantages of the high energy pulsed laser with a hair-thin water jet. While the laser is used for material ablation, the water jet is used for guiding the laser light, cooling the edges and allowing an excellent accuracy, advantages that are essential for cutting diamond samples with high quality.

This test shows that:

- Excellent quality is achievable on both side of the diamond. The edge roughness Ra is ${\sim}0.3\,\mu\text{m}.$
- The process time depends on the diamond thickness: from 10 minutes (6.5 mm thick) to 30 minutes for the 10 mm plate.
- The cut width is ~45 µm about 4 times less than your current process. This should allow you to produce more plates with one piece.

We thank you for your interest in our technology and we hope our results meet your requirements. Our Business Unit Manger Mr. Pausch will contact you soon to obtain a feedback about the analysis of these results and to discuss with you the further steps.